



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG831625820
Report verification at igi.org

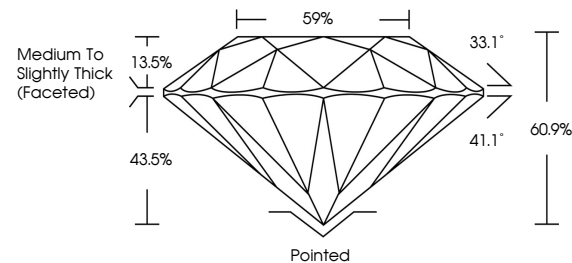
August 27, 2026	
IGI Report Number	LG831625820
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.14 - 8.18 X 4.97 MM
GRADING RESULTS	
Carat Weight	2.02 CARATS
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG831625820

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

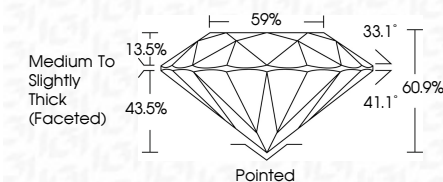
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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August 27, 2026	Carat Weight	2.02 CARATS
G1 Report No. LG3811635820	Color Grade	E
ROUND BRILLIANT	Clarity Grade	VVS 2
	Cut Grade	IDEAL
	Depth	60.9%
	Table	89%
	Grille	Medium to slightly Thick Faceted
	Culet	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Inscriptions(s)	lgf LG3811635820

Comments:

This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) process.

Type IIc